

**Notice of References Cited**

Application/Control No.

10/789,119

Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.

Examiner

SHANTELL HEIBER

Art Unit

2617

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**U.S. PATENT DOCUMENTS**

*		Document Number		Date	Name	Classification
		Country Code-Number-Kind Code		MM-YYYY		
*	A	US-2003/0066082		04-2003	Kliger et al.	725/80
	B	US-				
	C	US-				
	D	US-				
	E	US-				
	F	US-				
	G	US-				
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**FOREIGN PATENT DOCUMENTS**

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